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U.S. UTILITY Patent Application

PATENT NUMBER and
ISSUE DATE

APPL NUM 10090759	FILING DATE 03/06/2002	CLASS 216	SUBCLASS 1746	GAU 1746	EXAMINER
**APPLICANTS: Kaji Tetsunori; Kimura Shizuaki; Usui Tatehito; Fujii Takashi;					
**CONTINUING DATA VERIFIED:					
** FOREIGN APPLICATIONS VERIFIED: JAPAN 2001-364626 11/29/2001					
PG-PUB <input type="checkbox"/>		DO NOT PUBLISH <input type="checkbox"/>		RESCIND <input type="checkbox"/>	
Foreign priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 conditions met <input type="checkbox"/> yes <input type="checkbox"/> no Verified and Acknowledged Examiners's initials				ATTORNEY DOCKET NO 500.41316X00	
TITLE : Emission spectroscopic processing apparatus and plasma processing method using it					

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Assistant Examiner	
ISSUE FEE		DRAWING	
Amount Due	Date Paid	Total Claims	
		Print Claim for O.G.	
		Sheets Drwg. Figs.Drwg. Print Fig.	
		Primary Examiner	
		Application Examiner	
<input type="checkbox"/> TERMINAL DISCLAIMER		PREPARED FOR ISSUE	
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